OCT 0 4 2006

PATENT
Atty. Dkt. No. APPM/008403/MASK/MASK-ETCH/ARNOLD S

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Satitpunwaycha et al.

Serial No.: 10/782,300

Filed: 02/18/04

For: Tuned Potential Pedestal for Mask Etch Processing Apparatus

§ Confirmation No.: 4286
§
§ Group Art Unit: 1763
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§ Examiner: Rakesh Kumar Dhingra
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LIE
Please ENTER
Rakesh
10/16/06

MAIL STOP AF
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Dear Sir:

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, or electronically transmitted to the U.S. Patent and Trademark Office via EFS-Web, or facsimile transmitted to fax number 571.273.8300, to the attention of Examiner Rakesh Kumar Dhingra, on the date shown below:

October 4, 2006
Date

Keith M. Tackett

SUPPLEMENTAL RESPONSE TO FINAL OFFICE ACTION DATED JULY 6, 2006

In response to the Final Office Action dated July 6, 2006, having a shortened statutory period for response set to expire on October 6, 2006, please enter this supplemental response and reconsider the claims pending in the application for reasons discussed below. Although Applicants believe that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/008403/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 5 of this paper.

PAGE 2/8 * RCVD AT 10/4/2006 11:08:13 AM [Eastern Daylight Time] * SVR:USPTO-EFXRF-2/12 * DNIS:2738300 * CSID:7136234846 * DURATION (mm-ss):02-26